

Attorney Docket No.: MEMS-0160-US

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): BROWN, et al.

Conf. No.:

Application No.: 09/895,152

Art Unit: 1756

Filed: 2 Jul 2001

Examiner:  
Chacko Davis, DaborahTitle: HIGH QUALITY LITHOGRAPHIC  
PROCESSINGCommissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**REPLY AND/OR AMENDMENT**

Sir:

In response to the Examiner's Advisory Action dated December 2, 2004 the following Amendments and remarks are respectfully submitted in connection with the above-identified application.

**Deposit Account Authorization**

Please charge any shortage in fees due in connection with the filing of this, concurrent and future replies, including extension of time fees, to Deposit Account 50-3136 and please credit any excess fees to such deposit account.

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 8 of this paper.

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